



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

## REPLY TO OFFICE ACTION DATED 08/07/03

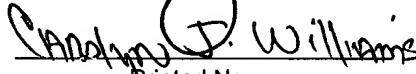
Atty. Docket No.  
DUPONT1120-1

Applicants Michael J. Penberth, et al.	
Application Number 09/262,778	Date Filed 03/04/99
Title <b>Electron Beam Blanking Method and System for Electron Beam Lithographic Processing</b>	
Group Art Unit 2625	Examiner <b>Chawan, Sheela C.</b>
Confirmation Number: 9973	

Certificate of Mailing Under 37 C.F.R. §1.8

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22312-1450 on October 21, 2003.

  
Signature  
  
Printed Name

Dear Sir:

In response to the Official Action mailed August 7, 2003, Applicants respectfully request that the Examiner reconsider the rejections of the Claims in view of this reply.

RECEIVED

OCT 28 2003

Technology Center 2600